Se	arch No	otes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/722,459	KIM ET AL.
Examiner	Art Unit
Jason P. Riggleman	1746

	SEAR	CHED	
Class	Subclass	Date	Examiner
68	12.02, 12.06, 12.27, 12.24	9/15/2006	JPR JPR JPR
140		9/19/2006	SPR
68	23.1	9/15/2006	g P R

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Class	Subclass	Date	Examiner
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DATE	EXMR
9/19/2006	Jer
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